

Te-hyperdoped Silicon Carrier Dynamics

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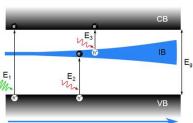
Motivation

Te-hyperdoped silicon

Results(continued) From Fig. 4, we observed significantly smaller carrier

Silicon (Si) semiconductors have been used in a broad range of fields including photodetection devices and solar cells. Nevertheless, the photoresponsivity of intrinsic Si semiconductor has been limited by its 1.12-electron volt **band gap**. One way of expanding the wavelength that intrinsic Si semiconductor can use is through doping. Adding dopants into the semiconductor introduces an intermediate band between valence band and conduction. Moreover, under decreasing temperature, band. This facilitates electron excitation for low energy photons. However, such impurities inside the Si semiconductor also accelerate carrier recombination, a process, assisted by dopants, which electrons decay into valence hand.

Fig. 1 Visualization of photoexcitation with the help of intermediate band (IB) with varying doping concentration (impurity). Adapted from Ref [1]



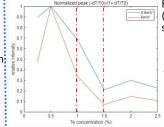
Impurity concentration

Tellurium (Te) has been shown as a potential dopant for Si semiconductors. It has a low diffuse rate in Si substrate [2], allowing doping concentrations beyond material's solubility limit (called hyperdoping). Te-hyperdoped Si also shows 105 thermal stability up to 400 Celsius [2]. Te-hyperdoped Si photodetectors show increasing spectral responsivity [2].

In our experiments, we used Tehyperdoped Si samples with peak concentrations of 0.25%, 0.5%, 1%, 1.5%, Ref [2] 2%, and 2.5%.

Fig. 3 Spectra Detectivity as a function of wavelength under zero bias at different temperatures from 20 to 300 K. Adapted from

lifetime for 0.25% and 1.5% sample in both 0.6 and 6mW pump power. For 0.6mW, the background noise was high for samples above 1.5% due to thermal excitation. Fig. 5 Normalized peak intensity of



From Fig 5, the normalized

decrease between 1% to

transition (IMT) for Te-

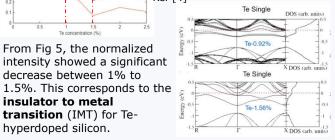
insulator to metal

hyperdoped silicon.

intensity showed a significant

 $(-\Delta T/T0)/(1 + \Delta T/T0)$ to 0.5% sample at each pump power

Fig. 6 Band structure and density of states for 0.92% and 1.56% Te-hyperdoped Si. Adapted from Ref [4]



Research Question

To understand why light detection properties depends on temperature, we want to study how temperature variation influences carrier recombination and carrier lifetime. This summer, the focus is on characterizing a set of samples and appropriate pump power for temperature dependent study.

Experimental Set-up

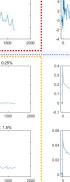
We measured carrier lifetime using a non-contact method called time-resolved terahertz spectroscopy (TRTS). Terahertz waves (THz) are sensitive to free carriers in the material. By sending THz signal through Te-hyperdoped silicon before and after photon excitation, we can find the change in conductivity of the material. Optical pump was set to be a 400nm laser with pump power of 6mW and we varied pump power using ND filters.



Results

using the following relation [3]: Fig. 4 $(-\Delta T/T0)/(1 + \Delta T/T0)$ measured as a function of time

and 6mW pump power.



Moreover, the two normalized curves in fig. 5 did not coincide with each other. This showed there is a nonlinear The time-dependent conductivities of the samples were calculated relation between pump power and peak conductivity. Hence, we performed a pump dependence measurement for 1% and 2% sample. We also fitted the curves with a for every concentration under 0.6 bi-exponential decay model for quantitative comparison.

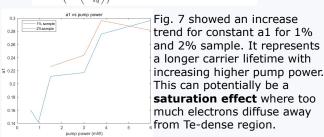


Fig. 7 Fitting constant a1 versus pump power for both 1% and 2%

Future work:

- Perform temperature dependent measurement for 1% and 2% sample to observe samples above and below IMT.
- Use 1mW pump power prevent saturation effect and reduce background noise.
- Test samples' crystallinity to explain whether 1.5% and 0.25% sample behave differently due to crystal structure.

Fig. 2 Time-resolved (TRTS) set-up.

Work Cited

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